## **DECLARATION**

As a below named inventor, I hereby declare that:

My residence, post office address and citizenship are as stated below next to my name.

I believe I am the original, first and sole inventor (if only one name is listed below) or the below named inventors are the original, first and joint inventors (if plural names are listed below) of the subject matter which is claimed and for which a patent is sought on the invention entitled METHOD OF FABRICATING COPPER-BASED SEMICONDUCTOR DEVICES USING A SACRIFICIAL DIELECTRIC LAYER, the Specification of which:

	was filed on	as Application S	erial No	
I her including the	-	eviewed and understa	and the contents of the a	above-identified specification,
material to pa				formation known to me to be riality" is defined in Title 37,
patent, United any foreign ap	States provisional appli	cation(s), or inventor's ted States provisional	certificate listed below a	any foreign application(s) for and have also identified below certificate having a filing date
	PRIO	PRIORITY APPLICATION(S)		Priority Claimed
(Number)	(Count	ry)	(Date Filed)	Yes/No
(Number)	(Count	ry)	(Date Filed)	Yes/No
listed below a United States acknowledge t claimed in thi	nd, insofar as the subject application in the mannithe duty to disclose all it is application, as "mate able between the filing desired.	t matter of each of the ter provided by the fin formation known to riality" is defined in	e claims of this application of Title 35, me to be material to pate Title 37, Code of Federa	y United States application(s) on is not disclosed in the prior. United States Code, § 112, I entability of the subject matter il Regulations, § 1.56, which PCT international filing date of
(App	olication Serial No.)	(Filing Date)	(Status)	
	olication Serial No.)	(Filing Date)	(Status)	

I hereby direct that all correspondence and telephone calls be addressed to Randall C. Furlong, Ph.D., Williams, Morgan & Amerson, P.C., 7676 Hillmont, Suite 250, Houston, Texas 77040, (713) 934-4061.

I HEREBY DECLARE THAT ALL STATEMENTS MADE OF MY OWN KNOWLEDGE ARE TRUE AND THAT ALL STATEMENTS MADE ON INFORMATION AND BELIEF ARE BELIEVED TO BE TRUE; AND FURTHER THAT THESE STATEMENTS WERE MADE WITH THE KNOWLEDGE THAT WILLFUL FALSE STATEMENTS AND THE LIKE SO MADE ARE PUNISHABLE BY FINE OR IMPRISONMENT, OR BOTH, UNDER SECTION 1001 OF TITLE 18 OF THE UNITED STATES CODE AND THAT SUCH WILLFUL FALSE STATEMENTS MAY JEOPARDIZE THE VALIDITY OF THE APPLICATION OR ANY PATENT ISSUED THEREON.

Inventor's Full Name:	STEPHEN KEETAI PARK			
Inventor's Signature:	Stew Pule			
Country of Citizenship:	KOREA	Date:	1-18/00	
Residence Address: (street, number, city, state, and/or country)	10043 Circle View Austin TK 7873	v Dr. 33	•	
Post Office Address: (if different from above)	same as above			

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

STEPHEN KEETAI PARK

Serial No.: Unknown

Filed: Concurrently Herewith

For:

METHOD OF FABRICATING COPPER-BASED SEMICONDUCTOR DEVICES USING A

SACRIFICIAL DIELECTRIC LAYER

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Examiner: Unknown

Group Art Unit: Unknown

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Atty Docket: 2000.029900/TT3586

## POWER OF ATTORNEY

**Assistant Commissioner for Patents** 

Washington, D.C. 20231

Sir:

The undersigned, being the inventor named in the above-identified application, hereby revokes any previous Powers of Attorney and appoints:

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as its attorney or agent so long as they remain with such firms, with full power of substitution and revocation, to prosecute the application, to make alterations and amendments therein, to transact all business in the Patent and Trademark Office in connection therewith, and to receive any Letters Patent, and for one year after issuance of such Letters Patent to file any request for a certificate of correction that may be deemed appropriate.

Please direct all communications as follows:

Randall C. Furlong, Ph.D. WILLIAMS, MORGAN & AMERSON, P.C. 7676 Hillmont, Suite 250 Houston, Texas 77040 (713) 934-4061

Signature:	- Atem C	Pule	Date:	1/18	100
	Stephen Keetai Parl				